

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination JENSEN ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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	U	"Cabot MMB enters CMP Market", Cabot Microelectronics Corp. Press Room, 07/12/1999 [retrieved 11/14/04], pages 1-2, retrieved from: google.com and archive.org.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

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